

CLIC Beam Dynamics, Alignment, Stability and Luminosity

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Luminosity

- The luminosity is given by

$$\mathcal{L} = H_D \frac{N^2 f_{rep} n_b}{4\pi\sigma_x\sigma_y}$$

$$\mathcal{L} \propto H_D \frac{N}{\sqrt{\beta_x \epsilon_x} \sqrt{\beta_y \epsilon_y}} \eta P$$

- Efficiency η depends on beam current that can be transported
 - \Rightarrow decrease bunch distance \Rightarrow long-range transverse wakefields in main linac
 - \Rightarrow increase bunch charge \Rightarrow short-range transverse and longitudinal wakefields in main linac, other effects
- Horizontal beam size σ_x
beam-beam effects, final focus system, damping ring, bunch compressors
- Vertical beam size σ_y
need to collide beams, beam delivery system, main linac, beam-beam effects, damping ring, bunch compressor
- Will go from IP to damping ring
 - \Rightarrow logical order

Beam Size Limit at IP

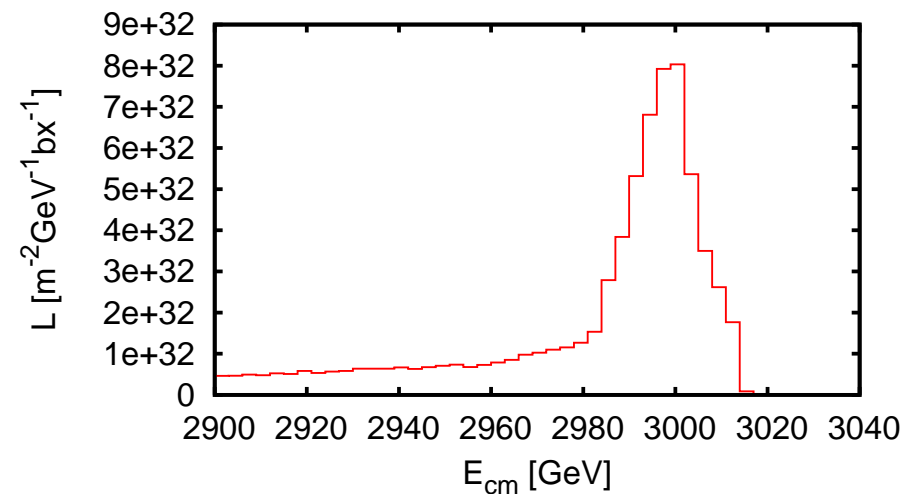
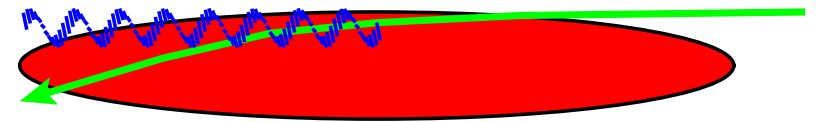
- The vertical beam size had been $\sigma_y \approx 1 \text{ nm}$ (BDS)
⇒ challenging, cannot be reduced much
- Fundamental limit on horizontal beam size arises from beamstrahlung

Photon emission grows with beamstrahlung parameter

$$\Upsilon = \frac{2\hbar\omega_c}{3E_0} \propto \frac{N\gamma}{(\sigma_x + \sigma_y)\sigma_z}$$

⇒ Lower limit for σ_x

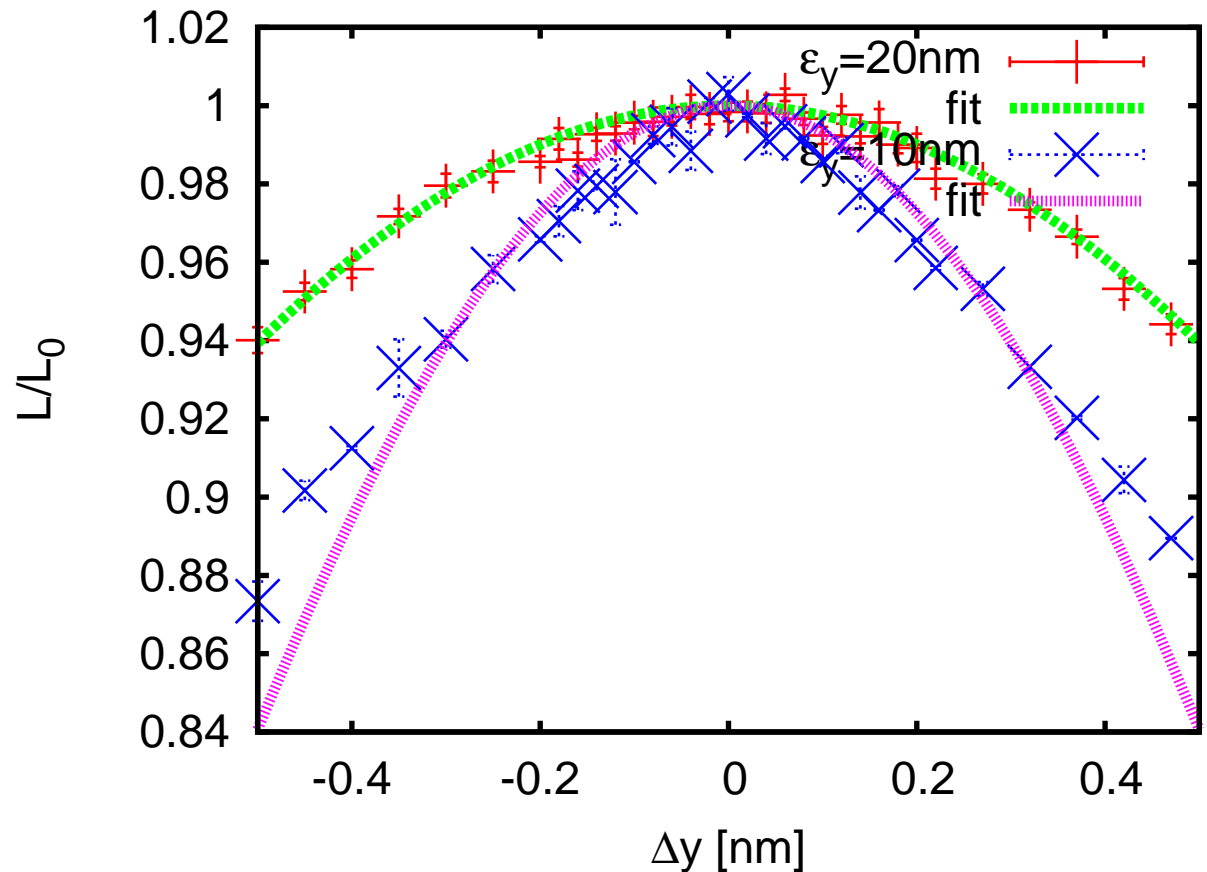
- In addition, horizontal emittance and beam delivery system make it difficult to achieve small σ_x



⇒ Relevant is luminosity in the peak

Beam-Beam Jitter Tolerance

- 0.2 nm beam-beam vertical position jitter leads to 1.0% luminosity loss
 - Inclusion of beam-beam effects finds almost the same values
 - 0.28 nm yields about 2%
- ⇒ tolerance on beam-beam jitter is ≈ 0.28 nm



- Limit value for enhancement of coherent beam jitter is

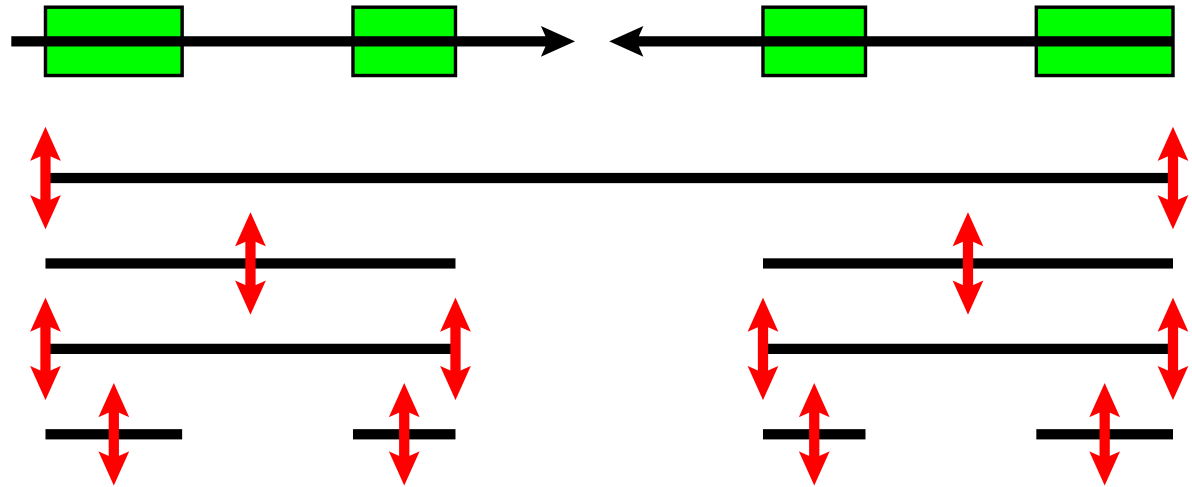
$$\Delta y = \frac{\Delta y_0}{1 - n_c \frac{4Nr_e}{\gamma\theta_c^2} \frac{\delta y'}{\delta \Delta y_0}}$$

- $\Delta y = 1.09\Delta y_0$

Final Doublet Jitter

- Final doublet jitter is most relevant source for beam jitter at IP
- One support structure

- relative tolerance on end points $\approx 4-5\sigma_{beam-beam}$



- Two support structures

- relative tolerance of mid points $\approx 0.7\sigma_{beam-beam}$
- relative tolerance of end points $\approx 0.64\sigma_{beam-beam}$

- Four support structures

- relative tolerance of mid points $\approx 0.5\sigma_{beam-beam}$

\Rightarrow Only one support seems excluded

\Rightarrow Chose two or four supports

- four is conservative ($\Rightarrow 0.14$ nm)
- two needs additional tolerance of motion on support ($\Rightarrow 0.18$ nm)

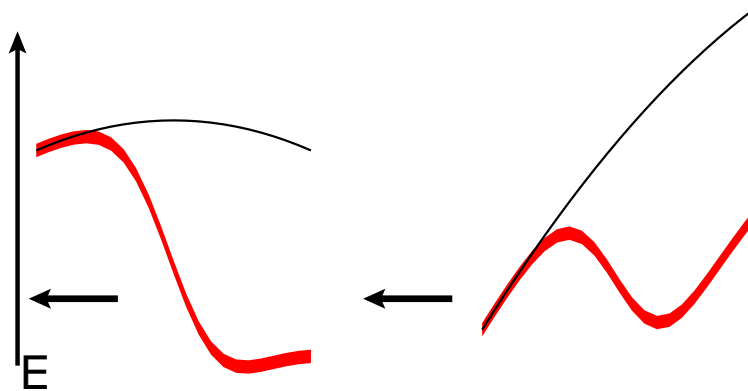
Main Linac Wakefield Effects

- Emittance growth scales as

$$\Delta\epsilon_y \propto (W_{\perp}\sigma_z)^2(\Delta y)^2 L_{\text{typical}}/G$$

⇒ aim for shortest possible bunch

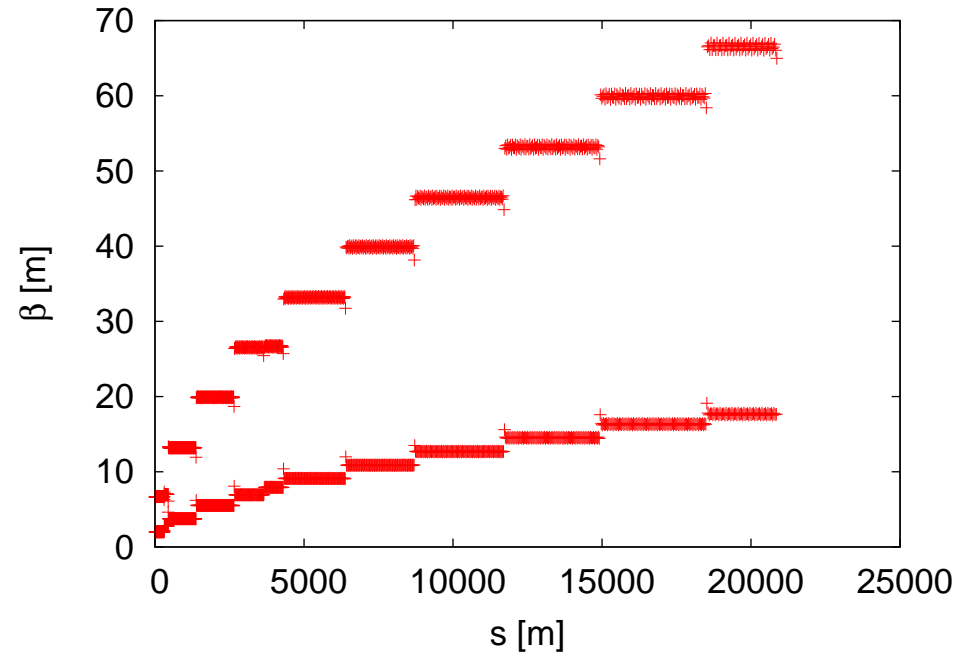
- Energy spread into the beam delivery system should be limited to about 1% full width or 0.35% rms
- Multi-bunch beam loading compensated by RF
- Single bunch longitudinal wakefield needs to be compensated
⇒ accelerate off-crest



- Limit around average $\Delta\Phi \leq 12^\circ$
⇒ $\sigma_z = 65 \mu\text{m}$ for $N = 5.2 \times 10$

Lattice Design

- Used $\beta \propto \sqrt{E}$, $\Delta\Phi = \text{const}$
 - balances wakes and dispersion
 - roughly constant fill factor
 - phase advance is chosen to balance between wakefield and ground motion effects
- Preliminary lattice
 - made for $N = 5.2 \times 10^9$
 - quadrupole dimensions need to be confirmed
 - some optimisations remain to be done
- Total length 20867.6m
 - fill factor 78.6%



- 12 different sectors used
- Matching between sectors using 5 quadrupoles to allow for some energy bandwidth

Single Bunch Dynamic Tolerances

- For jitters we assumed no correction

⇒ multi-pulse emittance is important

- Value is given for 0.1 nm emittance growth

- quadrupole position: 0.8 nm

- structure position: 0.7 μm

- structure angle: 0.55 μradian

⇒ Tolerances are very tight

- in particular for quadrupole

- ATL-model 1.2 nm for 10^5 s with $A = 0.5 \times 10^{-6} \mu\text{m}^2\text{s}^{-1}\text{m}^{-1}$ using one-to-one steering

⇒ tuning bumps are needed

- for three bumps 0.45 nm, for seven 0.25 nm

⇒ realignment every few days

Static Error Sources

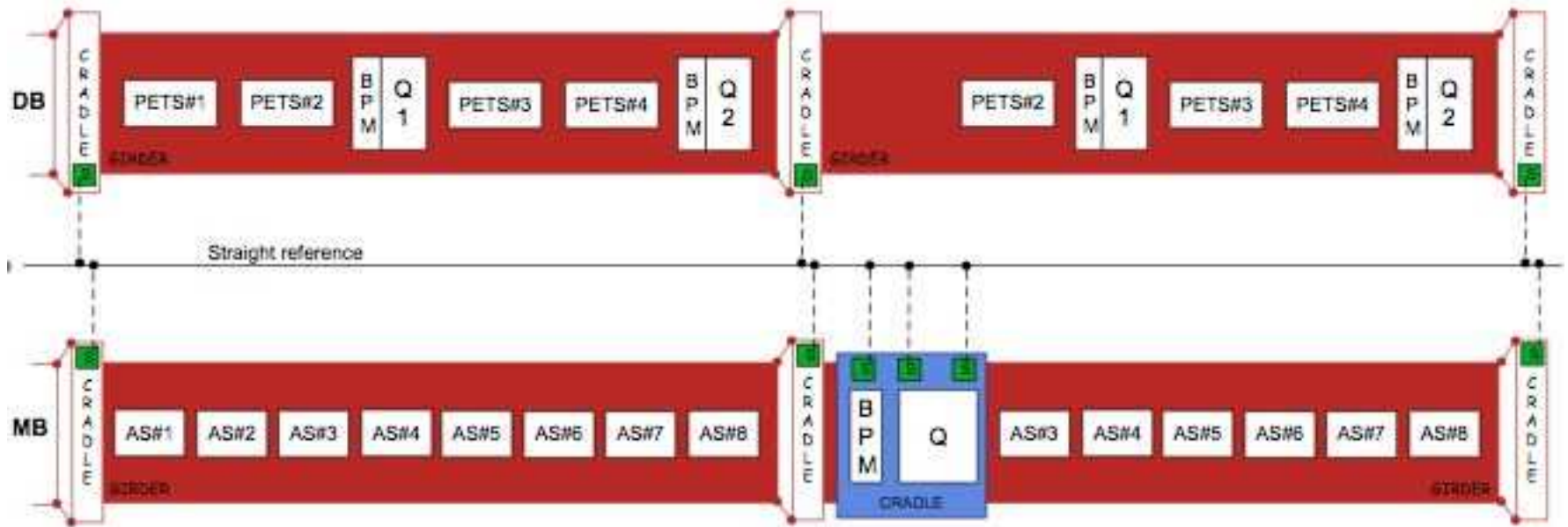
- Most important are
 - BPM position errors
 - BPM resolution
 - structure to beam offset
 - structure to beam angle
 - quadrupole roll
- BPM position errors and resolution determine the final dispersion left in the beam
- Structure offsets determine the final wakefield effect in the beam
 - if the wakefields are identical in two consecutive structures, the mean offsets is important
 - if wakefields are different, scattering of structures around mean value matters
 - should not matter for short-range wakefields
 - could matter for long-range wakefields

Main Linac Sensitivities

Element	error	with respect to	tolerance	
			CLIC	NLC
Structure	offset	beam	4.3(5.8) μm	5.0 μm
Structure	tilt	beam	220 μradian	135 μradian
Quadrupole	offset	straight line	—	—
Quadrupole	roll	axis	240(240) μm	280 μradian
BPM	offset	straight line	0.4(0.44) μm	1.3 μm
BPM	resolution	BPM center	0.4(0.44) μm	1.3 μm
Art. point	offset	straight line	1.7(3) μm	
End point	offset	Art. point	2.0(3.8) μm	

- All sensitivities for 1 nm growth after one-to-one steering
- Using DFS relaxes BPM position but constrains BPM resolution (example case 57 μm and 0.18 μm)
- Bumps help
- A bookshelving of 1 μm corresponds roughly to an angle error of 170 μradian

Misalignment Model: Module



- Sensors connect beam line to reference system
- Excellent prealignment of elements on the girders

(G. Riddone, module working group)

Pre-Alignment Performance

PRE-ALIGNMENT

Ref.	1	Inherent accuracy of reference	10 μm	1 σ
Ref. to cradle	2	Sensor accuracy and electronics (reading error, noise,..)	5 μm	1 σ
	3	Link sensor/cradle (supporting plates, interchangeability)	5 μm	1 σ
Cradle to girder	4	Link cradle/girder	5 μm	1 σ
Girder to AS	5a	Link girder/acc. structure	5 μm	1 σ
	5b	Inherent precision of structure		
TOTAL			14 μm	1 σ
Tolerance			40 μm	3 σ

BEAM-BASED ALIGNMENT

6) relative position of structure and BPM reading 5 μm 1 σ

(H. Mainaud Durand)

PRE-ALIGNMENT

Ref.	1	Inherent accuracy of reference	10 μm	1 σ
Ref. to cradle	2	Sensor accuracy and electronics (reading error, noise,..)	5 μm	1 σ
	3	Link sensor/cradle (supporting plates, interchangeability)	5 μm	1 σ
Cradle to Q	7a	Link cradle/quadrupole	5 μm	1 σ
	7b	Inherent precision of quadrupole	10 μm	1 σ
TOTAL			17 μm	1 σ
Tolerance			50 μm	3 σ

PRE-ALIGNMENT

Ref.	1	Inherent accuracy of reference	10 μm	1 σ
Ref. to cradle	2	Sensor accuracy and electronics (reading error, noise,..)	5 μm	1 σ
	3	Link sensor/cradle (supporting plates, interchangeability)	5 μm	1 σ
Cradle to BPM	8a	Link cradle/quadrupole BPM axis	5 μm	1 σ
BPM	8b	Inherent precision of quadrupole BPM axis	5 μm	1 σ
TOTAL			14 μm	1 σ
Tolerance			40 μm	3 σ

BEAM-BASED ALIGNMENT:

8c) relative position of quadrupole and BPM reading 10 μm 1 σ

Summary of Assumed Alignment Performance

Element	error	with respect to	alignment	
			NLC	CLIC
Structure	offset	girder	25 μm	5 μm
Structure	tilts	girder	33 μradian	RF structures
Girder	offset	survey line	50 μm	9.4 μm
Girder	tilt	survey line	15 μradian	9.4 μradian
Quadrupole	offset	survey line	50 μm	17 μm
Quadrupole	roll	survey line	300 μradian	$\leq 100 \mu\text{radian}$
BPM	offset	quadrupole/survey line	100 μm	14 μm
BPM	resolution	BPM center	0.3 μm	0.1 μm
Structure BPM	offset	wake center	5 μm	5 μm

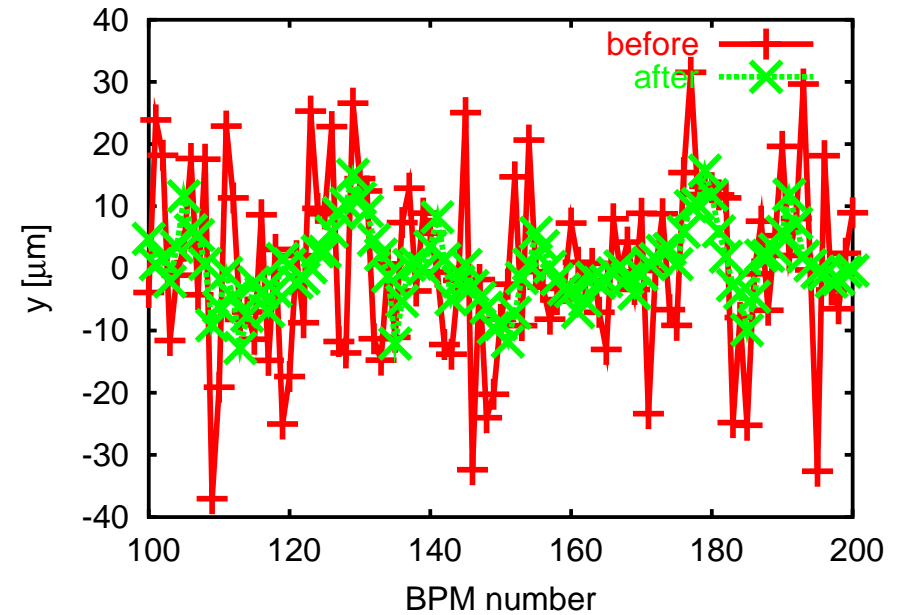
- Tolerances depend on the beam based alignment method
 - e.g. can trade-off BPM resolution against BPM alignment
- Budgets need a trade-off between different effects

Beam-Based Alignment and Tuning Strategy

- Make beam pass linac
 - one-to-one correction
- Remove dispersion, align BPMs and quadrupoles
 - dispersion free steering
 - ballistic alignment
- Remove wakefield effects
 - accelerating structure alignment
 - emittance tuning bumps
- Tune luminosity
 - tuning knobs
- currently noise during correction is being studied (e.g. beam or quadrupole jitter)

Dispersion Free Correction

- Basic idea: use different beam energies
- Accelerate beams with different gradient and initial energy



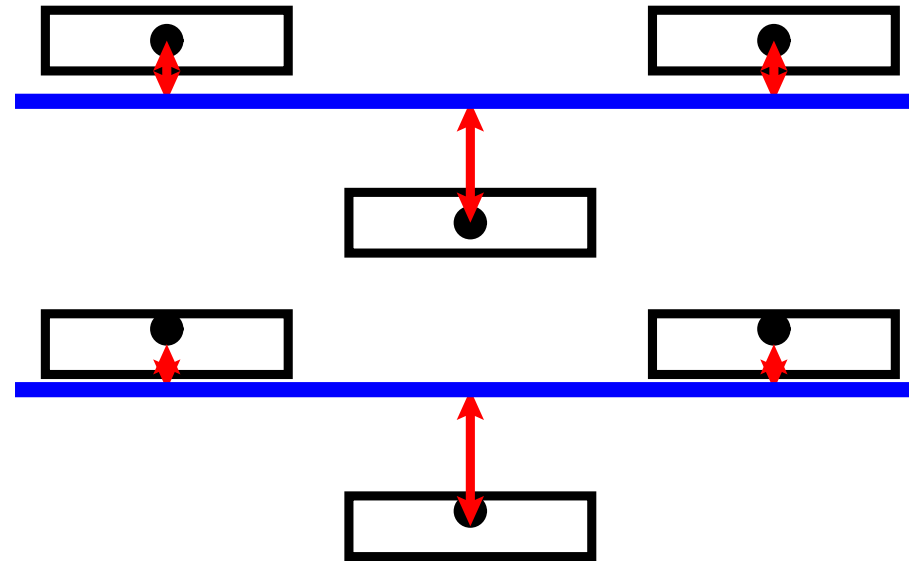
- Optimise trajectories for different energies together:

$$S = \sum_{i=1}^n \left(w_i (x_{i,1})^2 + \sum_{j=2}^m w_{i,j} (x_{i,1} - x_{i,j})^2 \right) + \sum_{k=1}^l w'_k (c_k)^2$$

- Last term is omitted
- Idea is to mimic energy differences that exist in the bunch with different beams

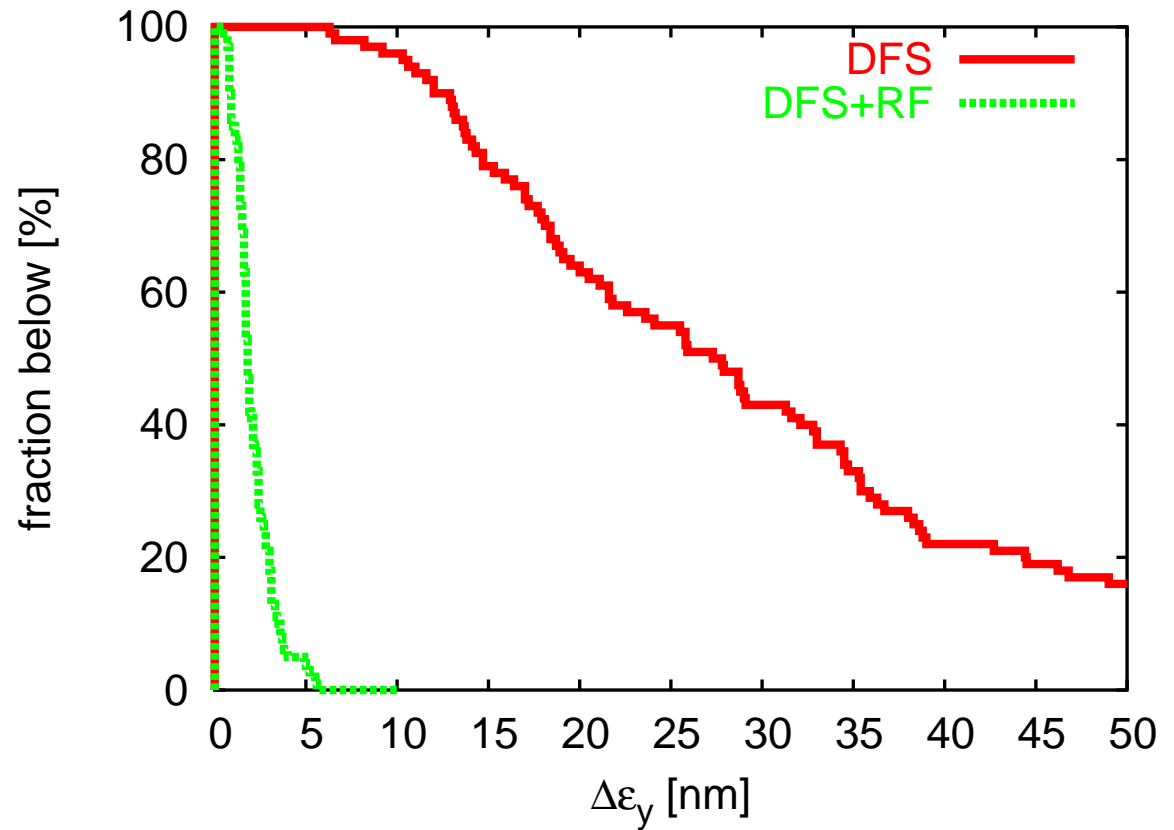
Beam-Based Structure Alignment

- Each structure is equipped with a BPM (RMS position error $5 \mu\text{m}$)
 - Up to eight structures are mounted on movable girders
- ⇒ Align structures to the beam
- A study had been performed to move the articulation points
 - ⇒ negligible additional effect if additional articulation point exists at quadrupoles
 - For wakes that are identical in each structure
 - relevant is error of structure BPM to structure centre
 - For wakes that differ from structure-to-structure
 - relevant is structure to beam offset



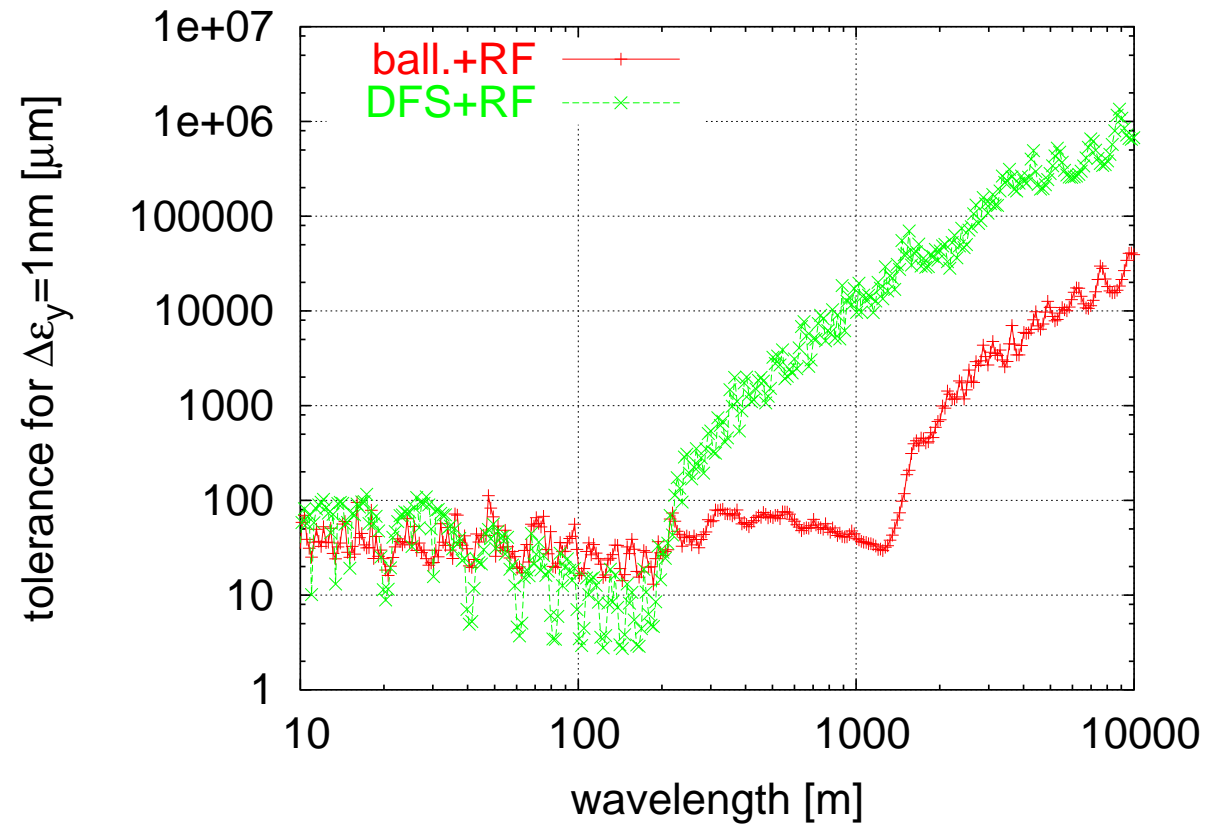
DFS Results

- ⇒ With RF alignment we can have more than 90% of the machines below 5nm
- ⇒ But not much margin



Long Distance Alignment

- Beam line elements are more difficult to align over long distances
 - we are investigating the alignment performance for this case
 - testing good material for long distance wires
- Simulation results to illustrate the point



⇒ The alignment tolerance depends on the correction method

Conclusion

- Element stability is vital for CLIC
 - very tight tolerance at interaction point
 - nanometer tolerance on all main linac quadrupoles
- Pre-alignment of beam line elements is vital
 - in particular good survey line over long distance
 - good alignment of BPMs to survey
 - good alignment of BPM to quadrupole (cost)
 - good alignment of structures on girder
 - precise structure fabrication
 - good structure BPM precision